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	<b>Filing Date</b>		2004-01-20
	<b>First Named Inventor</b>	Ronald J. Berenson	
	<b>Art Unit</b>	1651	
	<b>Examiner Name</b>	Taeyoon Kim	
<b>Attorney Docket Number</b>		980034.417C5	

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1	JACKSON et al., Small-Scale Monoclonal Antibody Production In Vitro: Methods And Resources, Proceedings of the Production of Monoclonal Antibodies Workshop, August 29, 1999, Bologna, Italy, <a href="http://altweb.jhsph.edu/topics/mabs/ardf/jackson.htm">http://altweb.jhsph.edu/topics/mabs/ardf/jackson.htm</a> , accessed April 17, 2007.	<input type="checkbox"/>
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